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**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takeyoshi ISOGAI et al.

Group Art Unit: 3729

Application No.: 10/041,624

Examiner: D. Nguyen

Filed: January 10, 2002

Docket No.: 111709

For: METHOD OF DETECTING POSITION OF ROTATION AXIS OF SUCTION  
NOZZLE, AND ELECTRIC-COMPONENT MOUNTING SYSTEM

**AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the November 25, 2003 Office Action, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**

**RECEIVED**  
**DEC 16 2003**  
TECHNOLOGY CENTER R3700